



## TRANSMITTAL OF FORMAL DRAWINGS

Docket No.

YOR920030194US1 (16695)

In Re Application Of: Cyril Cabral, Jr., et al.

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/643,534	August 19, 2003	Joannie A. Garcia	23389	2823	4259

Invention: ATOMIC LAYER DEPOSITION OF METALLIC CONTACTS, GATES AND DIFFUSION BARRIERS

Address to:

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Transmitted herewith are:

4 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

Signature

Dated: June 6, 2005

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Registration No. 39,394

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on

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